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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/907,911 07/19/2001 PAT 6,602,761  
which is a DIV of 09/356,704 07/20/1999 PAT 6,271,101

9/B

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 10-214125 07/29/1998

9/B

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 10/30/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 8
Verified and Acknowledged	Examiner's Signature: <i>William M. Bremley</i> Initials:				

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## TITLE

Process for production of SOI substrate and process for production of semiconductor device

## FILING FEE

FEES: Authority has been given in Paper  
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